



Docket No.: 42P17283

In Re the Application of:

MICHAEL MCSWINEY, ET AL.

Application No.: 10/750,062

Filed: December 30, 2003

For: **METHOD AND APPARATUS FOR LOW  
TEMPERATURE SILICON NITRIDE  
DEPOSITION**

Art Group: 1792

Examiner: Turocy, David P.

**PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F. R. § 1.136(a), Applicants for the above-identified application respectfully Petition the Commissioner for a one (1) month extension of time, extending the period for response to March 01, 2008, from the Office Action dated November 01, 2007. The petition filing fee of \$120.00 and an Amendment and Response to Office Action are attached. (If a check is not attached, you are hereby authorized to charge deposit account no. 02-2666.)

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional fees to Deposit Account No. 02-2666. A copy of the Fee Transmittal is enclosed for deposit account charging purposes.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP

Date: February 25, 2008

Jennifer Hayes, Reg. No. 50,845

**CERTIFICATE OF MAILING/TRANSMISSION**

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Carrie Boccaccini*  
Carrie Boccaccini

02-25-08

Date

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